



BTW

PATENT
Customer No. 22,852
Attorney Docket No. 04329.3157

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Hajime NAGANO et al.) Group Art Unit: 2818
Application No.: 10/675,950) Examiner: Le, Thao P.
Filed: October 2, 2003) Confirmation No. 5922
For: SEMICONDUCTOR DEVICE AND)
METHOD FOR MANUFACTURING)
PARTIAL SOI SUBSTRATES)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

RESPONSE TO RESTRICTION REQUIREMENT

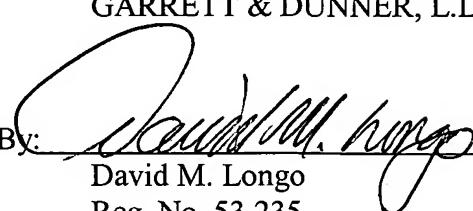
In the Restriction Requirement mailed March 1, 2005, with a period for response extending to April 1, 2005, the Examiner required restriction under 35 U.S.C. § 121 between Group I (claims 1-7) and Group II (claims 8-20). Applicants elect to prosecute Group I, claims 1-7, characterized by the Examiner as drawn to a semiconductor device, without traverse.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

By:


David M. Longo
Reg. No. 53,235

Dated: March 22, 2005

/direct telephone: (202) 408-4489/